



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 10, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG817634548

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.49 - 6.54 X 3.96 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.02 CARAT

D

VS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

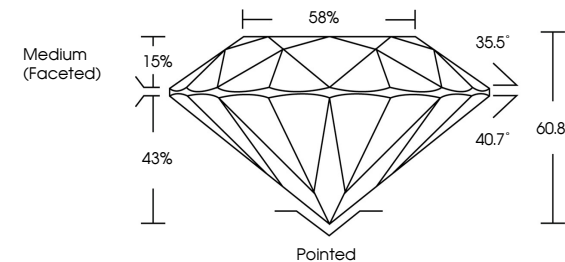
EXCELLENT

NONE

IGI LG817634548

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium (Faceted)

58%

35.5°

40.7°

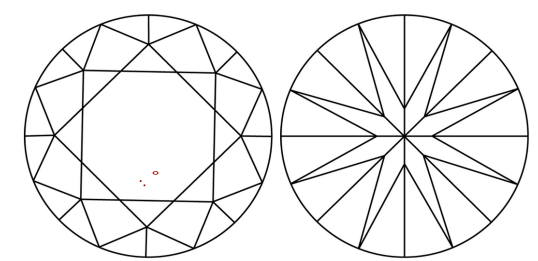
60.8%

15%

43%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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EXCELLENT

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NONE

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IGI

July 10, 2026

IGI Report No LG817634548

ROUND BRILLIANT

6.49 - 6.54 X 3.96 MM

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium (Faceted)

1.02 CARAT

D

VS 2

IDEAL

60.8%

88%

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG817634548

Cut

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

EXCELLENT

NONE

IGI LG817634548

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